ED AMENDMENT & PETITION FOR EXTENSION OF Docket No. IAR 0 2 2004 UTIME UNDER 37 CFR 1.136(a) (Large Entity) OKI.313 Ration Of: Noriyuki Miura Serial No. Examiner Group Art Unit Filing Date 10/092,499 March 8, 2002 **DUNG ANH LE** 2818 Invention: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND SEMICONDUCTOR DEVICE MAR 0 8 2004 TO THE COMMISSIONER FOR PATENTS: This is a combined amendment and petition under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the Office Action of ______in the above-identified application. The requested extension is as follows (check time period desired): ☐ Two months ☐ Five months ☑ One month ☐ Three months ☐ Four months 02/02/04 03/02/04 from: until: The fee for the amendment and extension of time has been calculated as shown below: CLAIMS AS AMENDED **CLAIMS REMAINING** HIGHEST # NUMBER EXTRA ADDITIONAL **RATE** AFTER AMENDMENT PREV. PAID FOR **CLAIMS PRESENT** FEE **TOTAL CLAIMS** 9 20 0 Х \$18.00 \$0.00 INDEP. CLAIMS 4 4 0 х \$86.00 \$0.00 \$0.00 FEE FOR AMENDMENT \$110.00 FEE FOR EXTENSION OF TIME \$110.00 TOTAL FEE FOR AMENDMENT AND EXTENSION OF TIME 03/05/2004 WABDELR1 00000021 10092499 01 Ft:1251 110.00 OP

TIME UNDER 37 CFR 1.136(a) (Large Entity)

Docket No. OKI.313

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The	e fee for the amendment and ex	tension of tim	ne is to be paid as	follows:		
\boxtimes	A check in the amount of	\$110.00	for the amendme	ent and exte	nsion of time is enclosed.	
	Please charge Deposit Account No.		in the	amount of	\$110.00	
	The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 5-=-239					
	☑ Any additional filing fees required under 37 C.F.R. 1.16.☐ Any patent application processing fees under 37 CFR 1.17.					
\boxtimes	If an additional extension of time is required, please consider this a petition therefor and charge any additional fees which may be required to Deposit Account No. 50-0238					
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	Signature		Dated:	MARCH 2	2, 2004	
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REG. NO. 33289				on	that this document and fee is being deposited with the U.S. Postal Service a mail under 37 C.F.R. 1.8 and is addressed to th	s
	ENTINE FRANCOS, PLLC SUNRISE VALLEY DRIVE, SI	JITE 150			oner for Patents, P.O. Box 1450, Alexandria, VA	
REST	ON VA 20191					
TEL. I	NO. (703) 715-0870			S	ignature of Person Mailing Correspondence	
cc:						

Typed or Printed Name of Person Mailing Correspondence

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Serial No. 10/092,499 OKI.313

Amendment Filed March, 2, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Noriyuki MIURA : Group Art Unit: 2818

Serial No.: 10/092,499 : Examiner: Dung Anh Le

Filed: March 8, 2002

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND SEMICONDUCTOR

DEVICE

AMENDMENT

U.S. Patent and Trademark Office 2011 South Clark Place Customer Window, Mail Stop Fee Amendment Crystal Plaza Two, Lobby, Room 1B03 Arlington, VA 22202

Sir:

In response to the Office Action of December 2, 2003, which issued in accordance with the practice under *Ex parte Quayle*, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Drawings begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 8 of this paper.